

Search Notes

Application/Control No.

10/667,973

Examiner

David Y. Chung

Applicant(s)/Patent under
Reexamination

FUJII ET AL.

Art Unit

2871

SEARCHED

Class	Subclass	Date	Examiner
349	110	3/7/2005	DC
349	113	3/7/2005	DC
349	129	3/7/2005	DC
349	130	3/7/2005	DC
349	106	3/7/2005	DC
349	43	3/7/2005	DC
349	114	3/7/2005	DC

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST search report	3/7/2005	DC
Consulted Ken Parker	3/7/2005	DC